



WP-2815

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: Zhiping Yin et al.  
Title: OXYGEN PLASMA TREATMENT FOR NITRIDE SURFACE TO REDUCE PHOTO FOOTING  
Docket No.: 303.531US1  
Filed: March 1, 1999  
Examiner: Jose Diaz  
Serial No.: 09/259,762  
Due Date: May 14, 2001  
Group Art Unit: 2815

Commissioner for Patents  
Washington, D.C. 20231

We are transmitting herewith the following attached items (as indicated with an "X"):

- X A return postcard.
- X A Response Under 1.111 (2 Pages).
- X A Power of Attorney by Assignee (1 pg.)

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Atty: Janal M. Kalis  
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**CERTIFICATE UNDER 37 CFR 1.8:** The undersigned hereby certifies that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail, in an envelope addressed to: Commissioner for Patents, Washington, D.C. 20231, on this 11 day of May, 2001.

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